

PATENT  
Attorney Docket No.: SAM-0483

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-eun Park, *et al.*  
Filing Date: Herewith  
Title: METHOD FOR FORMING SILICON DIOXIDE FILM USING  
SILOXANE

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2/19/04

Date



Kevin Biehl

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to prosecution on the merits, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.